

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Priority Application Serial No. ..... 09/475,545  
Priority Filing Date ..... December 30, 1999  
Inventor ..... Michael T. Andreas  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 3723  
Priority Examiner ..... G. Nguyen  
Attorney's Docket No. ..... MI22-1881  
Title: Chemical-Mechanical Polishing Methods

**PRELIMINARY AMENDMENT**

To: Box PATENT APPLICATION  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
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**AMENDMENTS**

**In the Specification**

At p. 1, before the "Technical Field" section, insert

**--RELATED PATENT DATA**

This patent resulted from a divisional application of U.S. Patent Application Serial No. 09/475,545, filed on December 30, 1999.--

**In The Claims**

Please cancel claims 1-25 and 39-70 without prejudice.

**REMARKS**

Claims 1-25 and 39-70 are canceled. Claims 26-38 are pending in the application.

Examination of claims 26-38 is requested.

Respectfully submitted,

Dated: 20 Nov 2001

By:   
James E. Lake  
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